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|--|-----------------|-------------------------------|---|--------------------------------|------|---------|-------|---------------------------------|----------------------------------|-------------------------------|---|
| APPLICANT'S ART CITATION <small>(Use several sheets if necessary)</small> | | Application 09/437,924 | | OFCS File No. P/2371-27 | | | | | | | |
| | | Applicant HIROSE, T. | | | | | | | | | |
| | | Filing Date 11/10/99 | | Group Art Unit 2766 | | | | | | | |
| U.S. PATENT DOCUMENTS | | | | | | | | | | | |
| Examiner Initials | Document Number | | | | Date | Name | Class | Sub- class | Filing Date if Appropriate | | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | | | | | |
| | Document Number | | | | Date | Country | Class | Sub- class | Translation | | |
| | | | | | | | | | Yes | No | |
| AW | 9- | 6 | 2 | 7 | 5 | 0 | | 3/1997 | JAPAN | | X |
| AW | 10- | 1 | 4 | 3 | 4 | 1 | 4 | 5/1998 | JAPAN | | X |
| AW | 5- | 1 | 5 | 1 | 3 | 4 | 3 | 6/1993 | JAPAN | RECEIVED | X |
| AW | 3- | 1 | 4 | 9 | 6 | 5 | 1 | 6/1991 | JAPAN | NOV 05 2003 | X |
| AW | 9- | 1 | 9 | 8 | 4 | 3 | 7 | 7/1997 | JAPAN | Technology Center 2100 | X |
| AW | 3- | 1 | 3 | 6 | 1 | 6 | 5 | 6/1991 | JAPAN | | X |
| AW | 5- | 1 | 0 | 1 | 0 | 8 | 1 | 4/1993 | JAPAN | | X |
| AW | 6- | 3 | 0 | 5 | 2 | 0 | 0 | 11/1994 | JAPAN | | X |
| AW | 6- | 3 | 4 | 8 | 7 | 0 | 4 | 12/1994 | JAPAN | | X |
| AW | 9- | 1 | 1 | 4 | 8 | 9 | 4 | 5/1997 | JAPAN | | X |
| AW | 5- | 2 | 1 | 6 | 9 | 7 | 5 | 8/1993 | JAPAN | | X |
| AW | 63- | 1 | 2 | 0 | 3 | 6 | 4 | 5/1988 | JAPAN | | X |
| AW | 61- | 2 | 0 | 4 | 7 | 6 | 6 | 9/1986 | JAPAN | | X |
| OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | | | | | |
| | | | | | | | | | | | |
| | | | | | | | | | | | |
| Examiner <u><i>[Signature]</i></u> | | | | | | | | Date Considered <u>12/10/03</u> | | | |
| <small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.</small> | | | | | | | | | | | |

APPLICANT'S ART CITATION

(Use several sheets if necessary)

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Data Considered

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